

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Group Art Unit: 2826
)	
Kaoru Koike, et al.)	Examiner: Erdem, Fazli
)	
Application No. 10/080,104)	
)	
Filed: February 21, 2002)	
)	
For: MASK-MAKING MEMBER AND ITS)	
PRODUCTION METHOD, MASK AND ITS)	
MAKING METHOD, EXPOSURE PROCESS,)	
AND FABRICATION METHOD OF)	
SEMICONDUCTOR DEVICE)	
)	
)	
)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO APRIL 20, 2006 NON-FINAL OFFICE ACTION

Dear Sir:

This is a Response to the Non-Final Office Action mailed April 20, 2006. In view of the amendments and remarks made herein, Applicants respectfully request reconsideration and allowance of the pending claims.